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**DELPHI TECHNOLOGIES, INC.**
**Legal Staff**
**P.O. Box 5052**
**Mail Code: 480-410-202**
**Troy, Michigan 48007-5052**

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Mail Stop Patent Applications
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Enclosed for filing are the following patent application papers:

Docket No.: DP-309888

Inventors : BOB XIAOBIN LI
MARK DAVID HEMINGWAY

Title : SURFACE DISCHARGE NON-THERMAL PLASMA REACTOR AND METHOD

Filing Fee Formula

| | | |
|---|---|---|
| Basic Fee | $ | 770.00 |
| Additional Fees: | | |
| Number of independent claims in excess of 3, times $86.00 | $ | 0.00 |
| Number of claims in excess of 20, times $18.00 | $ | 432.00 |
| Multiple dependent claim, add $290.00 | $ | 0.00 |
| Total Filing Fee | $ | 1202.00 |

The patent specification DP-309888 entitled SURFACE DISCHARGE NON-THERMAL PLASMA REACTOR AND METHOD and filed in the Patent and Trademark Office herewith is the patent specification for which the inventor(s) executed the Declaration enclosed herewith.

Please charge the $ 1202.00 filing fee to DELPHI TECHNOLOGIES INC. Deposit Account No. 50-0831.

JIMMY L. FUNKE
Reg. No. 34166
(248) 813-1214

Enclosures

I hereby certify that this document is being deposited with the United States Postal Service as Express Mail Post Office to Addressee addressed to Mail Stop Patent Applications, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on:

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